IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Shinsuke YAMANAKA et al.

Mail Stop: PCT

Serial No. NEW

Attorney Docket No. 2005 0973A

Filed June 21, 2005

OXIDE NANOSTRUCTURE, METHOD FOR PRODUCING SAME, AND USE THEREOF [Corresponding to PCT/JP2003/015961 Filed December 12, 2003]

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

la.

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicants request consideration of the references listed on attached form PTO-1449 and any additional information identified below in paragraph 3. A legible copy of each reference listed on the Form PTO-1449 is enclosed, except a copy is not provided for:

[X]	each U.S. Patent and U.S. Patent application publication;				
0	each reference previously cited in the international application PCT/; and/or				
O	each reference previously cited in prior parent application Serial No.				
[X] Thi	s Information Disclosure Statement is submitted:				
within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or					

before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,

and thus no certification and/or fee is required.

1b.	[] This Information Disclosure Statement is submitted				
	after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:				
	(1) [] the certification of paragraph 2 below is provided, or				

1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

(2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

- 2. It is hereby certified
 - a. [] that each item of information contained in this Information Disclosure

 Statement was first cited in any communication from a foreign patent office in a

 counterpart foreign application not more than three months prior to the filing of
 the Statement, or
 - b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.

- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.
- 4. For each non-English language reference listed on the attached form PTO-1449, reference is made to:
 - a. [X] a full or partial English language translation submitted herewith,
 - b. [X] a foreign patent office (International) search report (in the English language) submitted herewith (Attachment F),
 - c. [X] the concise explanation contained in the specification of the present application at page 1,
 - d. [X] the concise explanation set forth in the attached English language abstract,
 - e. [] the concise explanation set forth below or on a separate sheet attached to the reference:
- 5. [] A foreign patent office search report citing one or more of the references is enclosed.

Respectfully submitted,

Shinsuke YAMANAKA et al.

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Matthew M. Jacob

Registration No. 25,154

Attorney for Applicants

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Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 June 21, 2005

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Sheet 1 of 1			INFORMA	TION DISCLOSURE STATEMEN	JC17 Rec'd	PCT/PTO	21 JU	N 200		
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: June 21, 2005				ATTY DOCKET NO. 2005_0973A	IAL W	10/5	4023	ı		
				APPLICANT Shinsuke YAMANAKA et al.						
				FILING DATE June 21, 2005		GROUP				
U.S. PATENT DOCUMENTS										
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DA APPROPI			
	AA									
	АВ									
	AC									
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	AE									
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	,		FORE	IGN PATENT DOCUMENTS	•	_	,			
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EXAMINER

Takashi SUGIURA et al., "The control of a minute structure of TiO_2 surface by a photoelectrochemical etching", 18^{th} Discussion about Solid and Surface Photochemistry, November 1999.

DATE CONSIDERED